

Application/Control No.	Applicant(s)/Patent under Reexamination
10/532,849	MIURA ET AL.
Examiner	Art Unit
Nguyen T. Ha	2831

SEARCHED					
Class	Subclass	Date	Examiner		
361	301.3	2/27/2007	NH		
	523-525	2/27/2007	NH		
	528-530	2/27/2007	NH		
	516-519	2/27/2007	NH		
:	301.2	2/27/2007	NH		
	518-520	2/27/2007	NH		
	536-538	2/27/2007	NH		
UPDATE	SEARCH	7/16/2007	NH		
361	301.1	7/16/2007	NH		
	301.2	7/16/2007	NH		
	516-519	7/16/2007	NH		
	523-528	7/16/2007	NH		
•	536-538	7/16/2007	NH		
	503-512	7/16/2007	NH		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
SAME	AS	2/27/2007	NH		
ABOVE		7/16/2007	NH		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST SEARCH	2/27/2007	NH		
UPDATE SEARCH (SEE SEARH HISTORY)	7/16/2007	NH		
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